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CONFIRMATION NO. 7422

SERIAL NUMBER 10/680,216	FILING DATE 10/08/2003 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. P8375.0002
APPLICANTS Hidemitsu Aoki, Kanagawa, JAPAN; Yoshiko Kasama, Kanagawa, JAPAN; Tatsuya Suzuki, Kanagawa, JAPAN; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** JAPAN 2002-303629 10/17/2002 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/31/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Allowance</i> Acknowledged <i>Examiner's Signature</i> <i>Initials</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 2
ADDRESS 32172 DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP 1177 AVENUE OF THE AMERICAS (6TH AVENUE) 41 ST FL. NEW YORK , NY 10036-2714				
TITLE Method of manufacturing semiconductor device and apparatus for cleaning substrate				
FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)	